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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/325,951	06/04/1999	MIN-HSIUNG CHIANG	TSMC98-262	3488
7	590 06/14/2002			
GEORGE SAILE			EXAMINER	
20 MCINTOSI POUGHKEEP	H DRIVE SIE, NY 12603		POMPEY, RON EVERETT	
•			ART UNIT	PAPER NUMBER

2812

DATE MAILED: 06/14/2002

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Alicent(c)	(U~
		Application No.	Applicant(s)	
•	Office Action Comment	09/325,351	BARNES ET AL.	
	Office Action Summary	Examiner	Art Unit	
		Ron E Pompey	2812	
Period fo	The MAILING DATE of this communication a or Reply	ppears on the cover sheet with t	he correspondence addre	ss
THE - External after - If the - If NC - Failu - Any r	ORTENED STATUTORY PERIOD FOR REF MAILING DATE OF THIS COMMUNICATION nsions of time may be available under the provisions of 37 CFR SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a reperiod for reply is specified above, the maximum statutory perior to reply within the set or extended period for reply will, by state eply received by the Office later than three months after the mained patent term adjustment. See 37 CFR 1.704(b).	1. 1.136(a). In no event, however, may a reply leply within the statutory minimum of thirty (30 and will apply and will expire SIX (6) MONTHS ute, cause the application to become ABAND	be timely filed) days will be considered timely, from the mailing date of this commit ONED (35 U.S.C. § 133).	unication.
1)⊠	Responsive to communication(s) filed on 1	1 April 2002 .		
2a)⊠	This action is FINAL . 2b)	This action is non-final.		
3)☐ Dispositi	Since this application is in condition for allo closed in accordance with the practice undo on of Claims			nerits is
4) 🖂	Claim(s) 1.3-6 and 8-10 is/are pending in th	e application.		
	4a) Of the above claim(s) is/are withd	rawn from consideration.		
5) 🗌	Claim(s) is/are allowed.			
6)⊠	Claim(s) <u>1,3-6 and 8-10</u> is/are rejected.			
7) 🗌	Claim(s) is/are objected to.			
8)[Claim(s) are subject to restriction and	/or election requirement.		
	on Papers	·		
9) 🗌 .	The specification is objected to by the Examii	ner.		
10) 🔲 🗀	The drawing(s) filed on is/are: a)☐ acc	cepted or b) objected to by the E	Examiner.	
	Applicant may not request that any objection to	the drawing(s) be held in abeyance	. See 37 CFR 1.85(a).	
11) 🔲 🗀	The proposed drawing correction filed on	is: a)□ approved b)□ disap	proved by the Examiner.	
	If approved, corrected drawings are required in	reply to this Office action.		
12) 🔲 🗀	The oath or declaration is objected to by the I	Examiner.		
Priority u	ınder 35 U.S.C. §§ 119 and 120			
13)	Acknowledgment is made of a claim for forei	gn priority under 35 U.S.C. § 11	9(a)-(d) or (f).	
a)[☐ All b)☐ Some * c)☐ None of:			
	1. Certified copies of the priority docume	nts have been received.		
	2. Certified copies of the priority docume	nts have been received in Appli	cation No	
* 9	3. Copies of the certified copies of the pr application from the International E see the attached detailed Office action for a li	Bureau (PCT Rule 17.2(a)).		ge
	cknowledgment is made of a claim for dome	•		plication).
a	Digital The translation of the foreign language parts. The translation of the foreign language parts of the foreign language parts. The translation is made of a claim for dome	rovisional application has been	received.	,
Attachment	-	, ,		
1) Notic	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449) Paper No(s)	5) Notice of Inform	nary (PTO-413) Paper No(s) nal Patent Application (PTO-15	
S. Patent and Tr PTO-326 (Re		Action Summary	Part of Pape	 er No. 12

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DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1, 3-6, 8-10 are rejected under 35 U.S.C. 103(a) as being unpatentable over Higashitani et al. (US 5,637,528) in view of Wolf (Silicon Processing for the VLSI Era, Vol. 1, pg. 209-10).

Higashitani discloses the steps of:

For claims 1, 4, 6 and 8:

oxidizing the silicon substrate locally at a first temperature of at least above 1100 degrees centigrade through the patterned silicon nitride mask layer to form silicon oxide dielectric field oxide (FOX) isolation layers (col. 5, lns. 5-42).

Higashitani fails to disclose some or all the limitations of claims 6-8. However, Wolf is applied supra as to claim 6, discloses the steps of:

For claims 6-8:

oxidizing the silicon substrate further at a second temperature no greater than 1100 degrees centigrade (pg. 209-10, section-titled growth of thin oxides).

Therefore, it would have been obvious to a person of ordinary skill in the art at the time the invention was made to combine the steps of Wolf in Higashitani because oxidizing under lower temperature forms a more reliable gate oxide. The examiner would also like to take official notice that the limitations of claims 3, 5 and 9-10 are conventional: substrate materials, dry environment conditions and crystal orientations, in semiconductor processing of today.

Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

4. Claims 1 and 4 are rejected under 35 U.S.C. 102(b) as being anticipated by Liu et al. (US 5,739,063).

Liu discloses the steps of:

For claims 1 and 4:

oxidizing the silicon semiconductor substrate locally at a first oxidation temperature of at least above 1100 degrees centigrade through the silicon nitride mask pattern to form silicon oxide dielectric layers (col. 6, Ins. 27-34).

Response to Arguments

5. Applicant's arguments filed 4-11-02, pertaining claims 1, 3-6 and 8-10, have been fully considered but they are not persuasive. The applicant argues that the prior art does not accomplish the beneficial effects as disclosed by applicants claimed invention.

However, if the prior art performs similar processes, as claimed, the value added results will be the same.

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Therefore the rejection above is upheld.

Conclusion

6. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time

policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE

MONTHS from the mailing date of this action. In the event a first reply is filed within

TWO MONTHS of the mailing date of this final action and the advisory action is not

mailed until after the end of the THREE-MONTH shortened statutory period, then the

shortened statutory period will expire on the date the advisory action is mailed, and any

extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of

the advisory action. In no event, however, will the statutory period for reply expire later

than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Ron E Pompey whose telephone number is (703) 305-

3016.

Ron Pompey

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June 11, 2002

John F. Niebling

Supervisory Patent Examiner Technology Center 2800 Page 4